

Notice of References Cited	Application/Control No. 10/820,721	Applicant(s)/Patent Under Reexamination LIAO ET AL.	
	Examiner Ricardo Pizarro	Art Unit 2661	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0258561	12-2004	Reimer et al.	422/056
	B	US-2003/0119552	06-2003	Laumen et al.	455/557
	C	US-2004/0087336	05-2004	Payrits et al.	455/557
	D	US-2002/0065097	05-2002	Brockenbrough et al.	455/552
	E	US-2005/0198193	09-2005	Halme, Jaakko	709/217
	F	US-6,893,347	05-2005	Zilliacus et al.	463/41
	G	US-2003/0211856	11-2003	Zilliacus, Martin	455/466
	H	US-2003/0177230	09-2003	Stalker, Altan J.	709/224
	I	US-2003/0050062	03-2003	Chen et al.	455/435
	J	US-2003/0079020	04-2003	Gourraud et al.	709/227
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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